



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Saldana et al.

Application No: 09/748,708

Filed: December 22, 2000

For: POLISHING APPARATUS AND
METHODS HAVING HIGH PROCESSING
WORKLOAD FOR CONTROLLING POLISHING)
PRESSURE APPLIED BY POLISHING HEAD)

)
) Group Art Unit: 3723

)
) Examiner: Unassigned

)
) Atty. Docket No: LAM2421

)
) Date: November 11, 2003

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450, on November 11, 2003.

Signed: _____

Kay Harlow

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§1.56 AND 1.97(c)

Mail Stop: DD
Commissioner for Patents
Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement (IDS) is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0805 (Order No. LAM2P421).

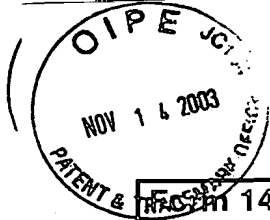
Respectfully submitted,

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Attorney Docket No. LAM2P421



Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Attorney Docket No: U.S. LAM2P421 10/607,613 Applicant: Kiermasz et al. Filing Date: Group: June 27, 2003 3723
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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	4,606,151	08/1986	Heynacher			
	B	4,850,152	07/1989	Heynacher et al.			
	C	5,575,707	11/1996	Talieh et al.			
	D	5,662,518	09/1997	James et al.			
	E	5,762,546	06/1998	James et al.			
	F	5,800,248	09/1998	Pant et al.			
	G	5,888,120	03/1999	Doran			
	H	5,888,126	03/1999	Hirose et al.			
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	K	5,961,372	10/1999	Shendon			
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	M	6,102,786	08/2000	Hirose et al.			
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	Q	6,234,878	05/2001	Moore			

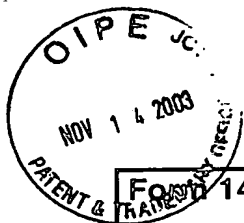
Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	R	EP0920956	06/1999	EPO			x	
	S	JP03259520	11/1991	JPO				x
	T	JP03259520	11/1991	Patent Abstracts of Japan			x	
	U	EP0881039	12/1998	EPO			x	
	V	FR2767735	08/1998	French Patent Office				x

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	W	
	X	
	Y	
	Z	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Form 1449 (Modified) Information Disclosur Stat ment By Applicant (Use Several Sheets if Necessary)	<table style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 60%;">Attorney Docket No:</td> <td style="width: 40%;">U.S.</td> </tr> <tr> <td>LAM2P421</td> <td>10/607,613</td> </tr> <tr> <td colspan="2">Applicant:</td> </tr> <tr> <td colspan="2">Kiermasz et al.</td> </tr> <tr> <td>Filing Date:</td> <td>Group:</td> </tr> <tr> <td>June 27, 2003</td> <td>3723</td> </tr> </table>	Attorney Docket No:	U.S.	LAM2P421	10/607,613	Applicant:		Kiermasz et al.		Filing Date:	Group:	June 27, 2003	3723
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	L						Yes	No
	M							
	N							
	O							
	P							

Other Documents

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	R	
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